

10/584771

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OLIFF & BERRIDGE, PLC

ATTORNEYS AT LAW

Application Data Sheet**Applicant Information**

Applicant Authority type::	Inventor
Primary Citizenship Country::	Japan
Status::	Full Capacity
Given Name::	Isao
Family Name::	YOKOKAWA
State or Province of Residence::	Gunma
Country of Residence::	Japan

Correspondence Information

Correspondence Customer Number::	25944
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Application Information

Application Type::	National Phase
Subject Matter::	Utility
CD-ROM or CD-R::	None
Title::	METHOD FOR MEASURING AN AMOUNT OF STRAIN OF A BONDED STRAINED WAFER
Attorney Docket Number::	128503
Suggested Drawing Figure::	3
Total Drawing Sheets::	8
Small Entity::	No

Representative Information

James A. Oliff, Reg. No. 27,075	William P. Berridge, Reg. No. 30,024
Thomas J. Pardini, Reg. No. 30,411	Edward P. Walker, Reg. No. 31,450
Robert A. Miller, Reg. No. 32,771	Mario A. Costantino, Reg. No. 33,565
Joel S. Armstrong, Reg. No. 36,430	Christopher W. Brown, Reg. No. 38,025
Paul Tsou, Reg. No. 37,956	Eric D. Morehouse, Reg. No. 38,565

Domestic Priority Information			
Application::	Continuity Type::	Parent Application::	Parent Filing Date::
This Application is a	National Phase of	PCT/JP2005/000165	January 11, 2005
Foreign Priority Information			
Country::	Application Number::	Filing Date::	Priority Claimed::
Japan	2004-8744	January 16, 2004	Yes
Assignee Information			
Assignee Name::		SHIN-ETSU HANDOTAI CO., LTD.	
Street of mailing address::		4-2, Marunouchi 1-chome, chiyoda-ku	
City of mailing address::		Tokyo	
Country of mailing address::		Japan	